

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jugo Mitomo
Serial No.: not yet assigned
Filed: August 22, 2001
For: SEMICONDUCTOR LASER AND
METHOD OF PRODUCTION THEREOF
Case No.: 9792909-5153
Group Art Unit: not yet assigned
Examiner: not yet assigned
Date: August 22, 2001

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Jo Ellen Hogan

8/22/01
Date

PRELIMINARY AMENDMENT ACCOMPANYING APPLICATION

Box Patent Application
Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Between the title and the heading "Background of Invention" on page 1, insert the following:

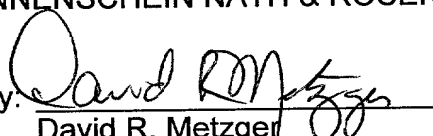
--RELATED APPLICATION DATA

The present invention claims priority to Japanese Application No. P2000-258139, filed August 23, 2000, which application is incorporated herein by reference to the extent permitted by law.--

Respectfully submitted,

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